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SERIAL NUMBER 10/699,503	FILING DATE 10/31/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 7335
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APPLICANTS

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** CONTINUING DATA *****

NONE

Lee

** FOREIGN APPLICATIONS *****

NONE

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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/02/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY IRELAND	SHEETS DRAWING 8	TOTAL CLAIMS 42	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>[Initials]</i>		

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TITLE

Method for forming a filled trench in a semiconductor layer of a semiconductor substrate, and a semiconductor substrate with a semiconductor layer having a filled trench therein

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
RECEIVED 1366		<input type="checkbox"/> 1.16 Fees (Filing)
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